



On etching, selection and measurement of confined fission tracks in apatite

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Abstract

1 This work investigates the selection of horizontal confined tracks for fission-track modelling. It is
2 carried out on prism sections of Durango apatite containing induced tracks with mean lengths of
3 ~16, ~14, ~12, and ~10 μm . Suitable tracks are identified during systematic scans in transmitted
4 light. The explicit selection criteria are that the tracks are horizontal and measurable. We meas-
5 ure the length, width, orientation, and cone angle of each selected track and in some cases other
6 dimensions.

7 The confined track selection is in the first place dependent on a threshold width and in the second
8 place on the requirement that the tracks are etched to their ends. In most cases the first condition
9 implies the second, which decreases in importance as the tracks are shortened following anneal-
10 ing. The widest confined tracks, which must also be the shallowest, come to intersect the surface
11 and are excluded. In general, the selection is dominated by the width of the etched tracks. This, in
12 turn, depends on their orientation relative to the c -axis and the apatite etch rates, and their effective
13 etch times. Despite the different geometrical configuration of the unetched host tracks and confined
14 tracks, neither the angular distribution nor the etch time distribution of the confined track
15 sample depends on the degree of annealing. This illustrates the general principle that those tracks
16 are selected that have the right properties for being selected. In this case etching-related factors
17 determining the track width are the most important, while the known geometrical biases are sec-
18 ond order. The track etch rate exhibits no demonstrable variation along the track, but significant
19 differences from track to track. Moreover, although the track etch rate of induced tracks is not
20 correlated with the extent of partial annealing, it is on average twice as high as the value for fossil
21 tracks.

22 Our length measurements are in good agreement with the annealing models for this apatite and
23 etch protocol. We submit that this is not fortuitous and that it is possible to select a representative
24 confined track sample, and perform reproducible and meaningful confined track length measure-
25 ments. Deliberate or inadvertent biasing, carelessness or inexperience will of course give differ-
26 ent results, but these should be treated as statistical outliers, not as an indication that track
27 lengths are fluid.

28 **Keywords:** apatite, fission-track, confined track etching, selection and measurement, track etch
29 rate

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1. Introduction

30 Fission-track analysis is a method for determining the ages of rocks and retracing their thermal
31 histories. It is based on the trails of lattice damage left in suitable minerals by the fragments of
32 fissioned uranium nuclei. The tools for interpreting fission-track data have evolved apace but
33 fundamental questions have remained unanswered. An important problem has to do with the
34 relationship between the actual damage trails and the fission tracks that are counted and meas-
35 ured after etching the mineral grains. Galbraith (2005) observed that "Inferring thermal histo-
36 ries from track measurements involves two steps. The first is to relate measurements made on
37 a sample to the true length distribution $f(l)$, and the second is to relate $f(l)$ to the thermal his-
38 tory". Several studies have addressed observational biases connected with measurements of
39 (horizontal) confined tracks. These are of a geometrical nature and their numerical treatment
40 is based on the so-called line-segment model. They include length bias, orientation bias, inter-
41 section (fracture and host track thickness) bias, and edge and surface proximity biases (Laslett
42 et al., 1982; 1984; Galbraith et al., 1990; Galbraith, 2002; 2005; Ketcham, 2003; 2005; Ketcham
43 et al., 2007).

44 In contrast to the geometrical biases, biases related to the actual etching of confined tracks are
45 less well understood. It was soon clear that the etching conditions (etchant, concentration, du-
46 ration and temperature) affected the lengths of confined tracks in apatite. Several experiments
47 with different etching protocols, listed in Jonckheere et al. (2017), showed that the mean length
48 of confined tracks first increased at a rapid rate up to a point where the tracks were considered
49 fully etched, following which it further increased at the much slower apatite etch rate (Laslett
50 et al., 1984). Watt et al. (1984) observed that the greater mean length of TinCLE's compared to
51 that of TinT's in the same sample could be explained by the time required for the host track to
52 etch, as compared to the almost immediate penetration of the etchant through a crack to reveal
53 the TinCLE's. Ketcham (2003) found that geometrical biases alone cannot account for the prop-
54 erties of confined track samples and proposed that "under-etching bias" was also an important
55 selection criterion.

56 Laslett et al. (1984) drew attention to the factors causing individual confined tracks to be etched
57 for a different time: "most confined tracks are over-etched in order to ensure that the etchant can
58 percolate down fractures and other tracks to etch all intersecting tracks (access time). Also, the
59 shortest tracks must be over-etched in order to ensure that the longest ones are fully revealed
60 (length)". These factors were integrated in numerical models (Rebetez et al., 1988; Ketcham
61 and Tamer, 2021), which showed that the lengths of etched confined tracks span the range from
62 zero length to that of the longest track. This implies that the measured track length distribution
63 is to some extent the product of an active selection based on a geometrical criterion or operator
64 bias (Ketcham and Tamer, 2021). Tamer et al. (2019) demonstrated the practical importance
65 of track selection; two operators mutually rejected $\sim 14\%$ of each other's selections. Ketcham
66 and Tamer (2021) guardedly concluded that the importance of selection "affects the fidelity of
67 thermal history modelling".

68 Step-etching of individual confined tracks in apatite showed that their lengths increase in erratic
69 fashion, with single 10s increments between ~ 0 and $>1 \mu\text{m}$, decreasing overall as the etch time
70 increases (5.5 M HNO_3 at 21 °C; Jonckheere et al., 2017). This underscores the importance of the
71 etch times of individual tracks for modelling of the confined track length distribution. Aslanian et
72 al. (2021) and Jonckheere et al. (2022) proposed a new etch model and measured the rates for
73 Durango apatite etched in 5.5 M HNO_3 at 21 °C. This permits to calculate the true duration (t_E) for
74 which an individual confined track has been etched from its orientation, shape and thickness. On
75 the one hand, it offers a practical criterion for selecting tracks for thermal history modelling, that
76 is independent of a person's judgement, and independent of the factors that caused a specific
77 measured track to have been etched for a given length of time. On the other, it presents a tool for
78 investigating the factors controlling t_E or the t_E -distribution of the measured population. In the
79 next sections we investigate the influences of the track density and length using Durango apatites



80 annealed to nominal mean lengths of ~ 16 , ~ 14 , ~ 12 and ~ 10 μm (Ketcham et al., 2015; Aslanian
81 et al., 2022).

2. Materials and Methods

82 To investigate the effects of partial annealing on the composition and properties of the confined
83 track population we carried out measurements on four prism sections of Durango apatite dis-
84 tributed for inter-laboratory comparisons. The samples had been pre-annealed, neutron-irra-
85 diated and - all except one - annealed again to create induced-track populations with nominal
86 mean lengths of ~ 16 μm (sample 21-2), ~ 14 μm (sample 21-4), ~ 12 μm (sample 21-1) and ~ 10
87 μm (sample 21-3). Details of the irradiation and annealing conditions are given in Ketcham et
88 al. (2015). The track densities measured in transmitted and reflected light are reported in
89 Aslanian et al. (2021).

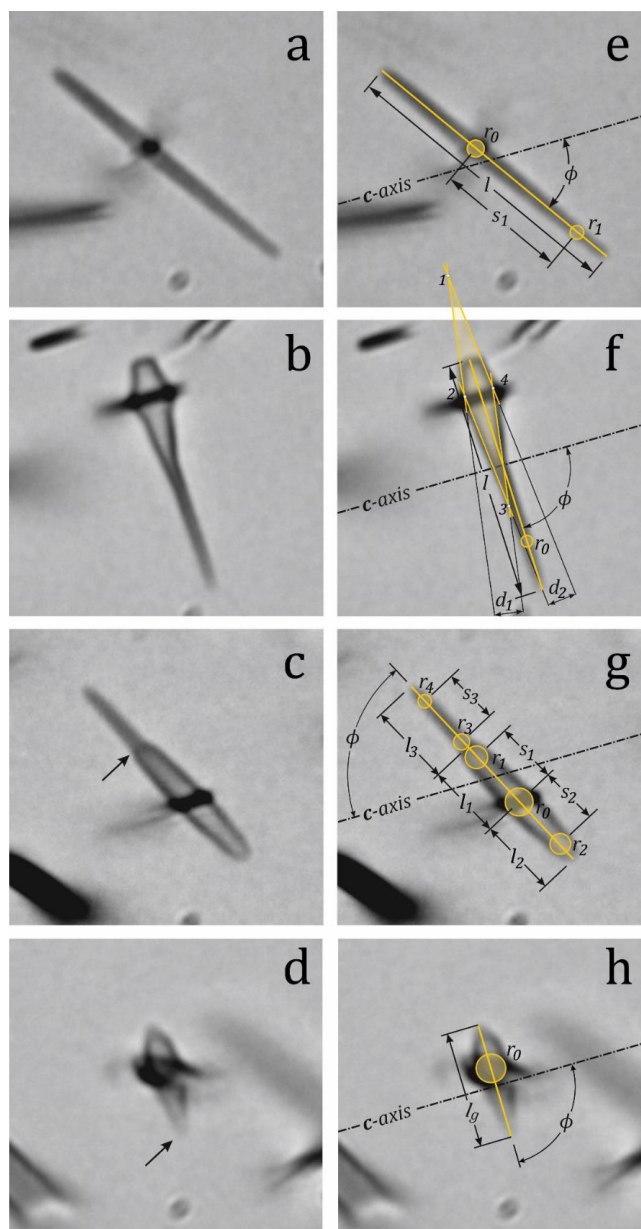
90 The samples were mounted in resin, ground on SiC papers, polished with 6-, 3-, and 1- μm dia-
91 mond suspensions, and given a final polish with 0.04- μm silica suspension, until the surface
92 was free of scratches under reflected light, and only faint scratches reappeared after etching.
93 All samples were etched for 20 s in 5.5 M HNO_3 at 21 $^\circ\text{C}$ (Carlson et al., 1999). The confined
94 track imaging was carried out with a motorized Zeiss Axiolmager Z2m microscope connected
95 to a desktop computer running the Autoscan program. The samples were systematically scanned
96 in transmitted light at an optical magnification of 250 \times (100 \times Epiplan Neofluar dry objective
97 and 2.5 \times optovar). We made image stacks of each confined track considered suitable for meas-
98 urement. This meant that both its ends were free, distinct and well etched, and that a sharp
99 image of the entire track was contained within a single stack of six frames with a fixed spacing
100 of 0.25 μm . For an 8- μm track this corresponds to a dip angle of $\arcsin(1.25/8) \approx 9^\circ$ and an error
101 of $< 2\%$. The advantage of this criterion is that it is clear and amenable to mathematical descrip-
102 tion. The disadvantage is that it introduces a bias in favour of short tracks proportional to their
103 reciprocal length, which acts counter to the conventional length bias (Laslett et al., 1982; 1984;
104 Galbraith et al., 1990).

105 Depending on the case, we extracted the best image from a stack or compressed a part of it to a
106 single image, converted it to eight-bit and loaded it in CorelDraw, cutting out a square frame con-
107 taining a single track to add to the database (**Figure 1a-d**). For calculating its effective etch time
108 (t_E) we measured its maximum width (r_0) at the intersection with its host track (TinT; **Figure**
109 **1e**) or, in rare cases, with a crack (TinCLE). For calculating the track etch rate (v_T), we measured
110 a second width (r_1) at some distance (s_1) from the first along a straight section of track. This
111 works for tracks at most angles to the c -axis ($\phi \lesssim 80^\circ$) but not for those at the highest ($\phi \gtrsim$
112 80°), where part of the channel is obscured by a diamond-shaped etch figure (**Figure 1f**; Jonck-
113 heere et al., 2022). As this figure is bounded by the fastest etching faces, a precise t_E -estimate is
114 obtained from measurements of the distances between opposing sides (d_1 and d_2). A less precise
115 lower estimate can still be obtained from the width of the channel outside the diamond shape
116 (r_0).

117 Some tracks at $\gtrsim 45^\circ$ to the c -axis in the most annealed sample have an atypical shape due to
118 "interrupted" etching at a "gap" in the latent track ("unetchable gap", Green et al., 1986). We
119 distinguish between "stepped" tracks where the gap was pierced during etching (**Figure 1c**)
120 and "gapped" tracks where it was not (**Figure 1d**; Galbraith, 2005). The latter are characterized
121 by their short lengths and irregular endings. We divided stepped tracks in three segments for
122 measurement (**Figure 1g**). The first, from the host track intersection to the gap, has length l_1 ;
123 the second, from the intersection in the opposite direction, has length l_2 ; the third, from the gap
124 to the other end, has length l_3 . The maximum width at the intersection with the host track is r_0 ;
125 those on either side of the gap are r_1 and r_3 ; the widths along segments 2 and 3 at a distance
126 from r_0 and r_3 are r_2 and r_4 .

127 From these measurements, we calculated the effective etch time (t_E) of each confined track as:

$$t_E(s) = 30 \frac{r_0(\mu\text{m})}{v_R(\mu\text{m}/\text{min})} \quad (\phi \lesssim 80^\circ) \quad (1a)$$



128 **Figure 1.** Etched confined tracks distinguished in this work: **(a)** continuous track at a low to moderate angle to the *c*-axis; **(b)** continuous track at a high angle to the *c*-axis, with a diamond shaped
 129 etch figure at its intersection with the host track; **(c)** stepped track showing narrowing (arrow)
 130 due an interruption of along-track etching; **(d)** gapped track with an abnormal termination (ar-
 131 row); **(e)** length (l), *c*-axis angle (ϕ) and width (r_0) of track (a); the width at r_1 and its distance (s_1)
 132 to r_0 are used to calculate the cone angle (θ) and the etch rate (v_T) of the track (equations 3a and
 133 b); **(f)** measurement of the distances (d_1 and d_2) between facing sides of the diamond shape at
 134 track (b), bounded by the fastest etching apatite faces, used for calculating its effective etch time
 135 (t_E ; equation 1b); **(g)** measurements of widths (r_0 , r_1 , r_2 , r_3 , and r_4) of track (c) aimed at determin-
 136 ing its effective etch time (t_E), the etch delay (t_D) at the constriction and the etch rates of the dif-
 137 ferent track sections; **(h)** measurement of the length (l), width (r_0) and orientation (ϕ) of the gap-
 138 ped track in (d).
 139



$$t_E(s) = 15 \frac{(d_1 + d_2)(\mu m)}{v_{R,MAX}(\mu m/min)} \quad (\phi \gtrsim 80^\circ) \quad (1b)$$

140 wherein v_R is calculated from the model of Aslanian et al. (2021), with $\phi_W = 90 - \phi$, and $v_{R,MAX} \approx$
 141 $3.0 \mu m/min$:

$$v_R(\mu m/min) = -0.0071 \phi_W^2 + 0.2807 \phi_W + 0.2495 \quad (\phi_W \lesssim 20^\circ) \quad (2a)$$

$$v_R(\mu m/min) = 0.00025 \phi_W^2 - 0.0633 \phi_W + 4.2500 \quad (\phi_W \gtrsim 20^\circ) \quad (2b)$$

142 The track etch rate v_T is calculated as:

$$v_T(\mu m/min) = \frac{v_R(\mu m/min)}{\sin(\theta/2)} \quad (3a)$$

143 wherein θ is the angle between facing straight margins of the track, calculated from r_0 , r_1 and s_1
 144 as:

$$\theta = 2 \arcsin\left(\frac{(r_0 - r_1)(\mu m)}{2 s_1(\mu m)}\right) \quad (3b)$$

145 The expected minimum and maximum widths for each track orientation are calculated from v_R
 146 (eqs. 2a and 2b) as:

$$r_{MAX}(\phi) (\mu m) = \left(\frac{2}{3}\right) (min) v_R(\phi_W) (\mu m/min) \quad (4a)$$

$$r_{MIN}(\phi) (\mu m) = \left(\frac{1}{5}\right) (min) v_R(\phi_W) (\mu m/min) \quad (4b)$$

147 where r_{MAX} refers to tracks etched for the full 20 s immersion time t_I , and r_{MIN} to the minimum
 148 time required for a track to be etched from its midpoint to both ends ($\approx 7.5(\mu m)/75(\mu m/min)$;
 149 Aslanian et al., 2021). We also estimated the maximum ($t_{E,MAX}$) and minimum ($t_{E,MIN}$) effective
 150 etch times. The maximum assumes that a track etches from the moment that the sample is im-
 151 mersed in the etchant till it is taken out and rinsed. The minimum assumes that a track must be
 152 etched for long enough to reach a width of $\sim 0.3 \mu m$, in order to be selected for measurement
 153 (Aslanian et al., 2021)

$$t_{E,MAX}(\phi) (s) = t_I \quad (5a)$$

$$t_{E,MIN}(\phi) (s) = 30 \frac{0.3 (\mu m)}{v_R(\phi_W) (\mu m/min)} \quad (5b)$$

3. Results and Discussion

154 From 2170 track images taken by one participant the other rejected 20 as not suitable for meas-
 155 urement. This $<1\%$ rejection rate is much lower than the averages of both participants in the
 156 investigation of Tamer et al. (2019; $\sim 14\%$). However, the present is a one-way rate concerning a
 157 single set of images taken using one set of etching and observation conditions. Also in contrast to
 158 the present, the latter investigation was of in general lower densities of fossil tracks in ^{252}Cf -irra-
 159 diated samples.

3.1 Track lengths

160 Plots of the measured (l) and the c -axis projected lengths (l_P ; Donelick et al., 1999) of horizontal
 161 confined tracks against angles to the c -axis (ϕ) illustrate the known length shortening and in-
 162 creasing anisotropy with increasing annealing (Figure 2; Green et al., 1986; Donelick, 1991). The
 163 mean lengths (l_M) are close to the values predicted by the annealing equations for Durango ap-



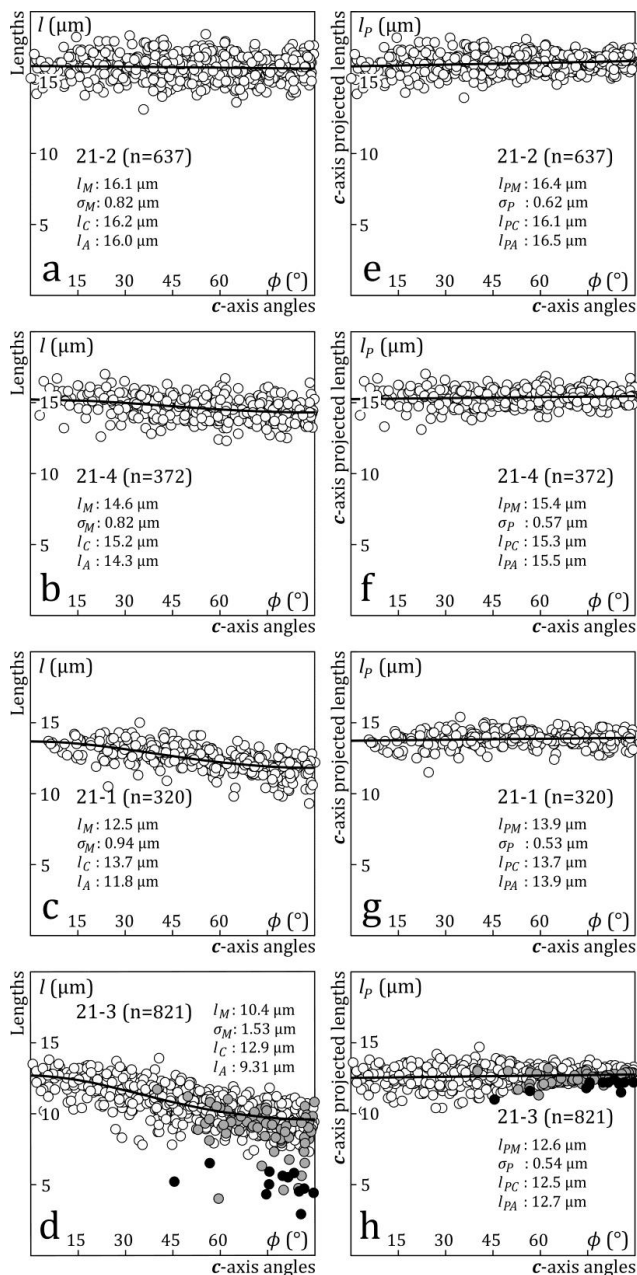
164 atite etched 20 s in 5.5 M HNO₃ at 21 °C (Ketcham et al., 1999; **Table 1**). The maximum differ-
165 ence (0.15 μm) is that between the measured mean length (10.45 μm) and that predicted by
166 the fanning rectilinear model for the most annealed sample (21-3; 10.30 μm). All other differ-
167 ences between measured and predicted mean lengths are <0.05 μm. The standard deviations
168 of the length distributions (S_M) are also in agreement with model predictions, with a maximum
169 difference between the measurements and models of 0.08 μm for sample 21-1 (**Table 1**). The
170 relationship between the standard deviations (S_M) and means (l_M) of the track length distributions
171 as well as that between the c -axis (l_C) and a -axis intercepts (l_A) of ellipses fitted to the length vs.
172 orientation data are consistent with the equations of Donelick et al. (1999; **Figure 3a**). The agree-
173 ment between our data and those reported in Carlson et al. (1999) shows that independent sci-
174 entists working two decades apart on samples annealed at different conditions, using different
175 equipment and measurement methods, but the same etching protocol, nevertheless produce con-
176 sistent results. We believe that this is not without significance and return to the issue later in the
177 discussion.

178 **Figure 2** plots the c -axis-projected length of each track against its actual angle to the axis (Donelick
179 et al., 1999). The agreement between the mean c -axis-projected lengths (l_P) and the annealing
180 models (Ketcham et al., 1999) is somewhat worse than for the non-projected lengths. The calcu-
181 lated values are 0.21-0.33 μm above the predictions of both the rectilinear and curvilinear models
182 (Table 1). In contrast, the standard deviations (S_P) are all within 0.05 μm of their predicted values.
183 The relationship between S_P and l_P is again consistent with the equation of Donelick et al. (1999;
184 **Figure 3b**). Except for a small offset of 0.2-0.5 μm, the c -axis (l_{PC}) and a -axis (l_{PA}) intercepts of
185 regression lines fitted to the (l_P, ϕ)-data are almost identical, indicating that c -axis projection ef-
186 fectively eliminates the anisotropy of the track lengths in the annealed and unannealed samples
187 (**Figure 3a**).

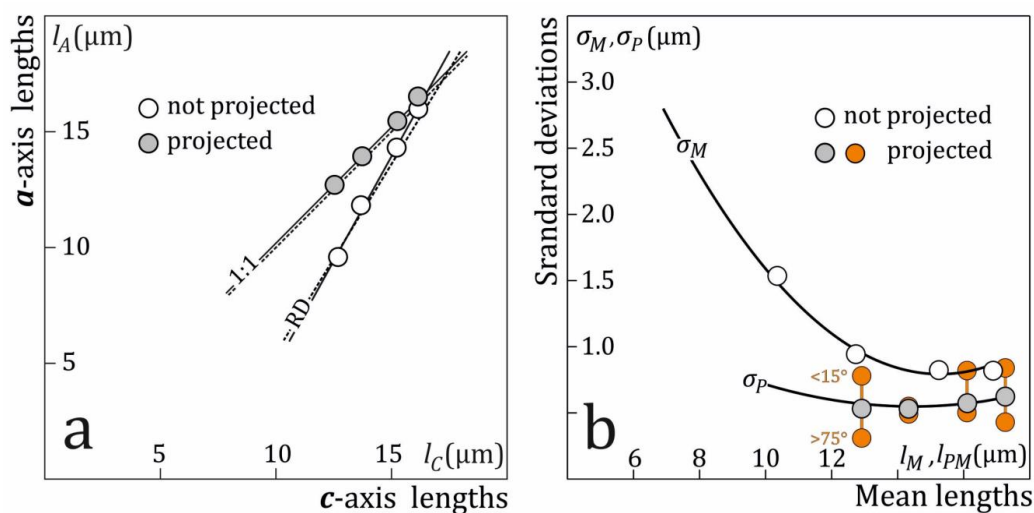
188 Although it is most noticeable in the case of sample 21-3 (**Figure 2h**), l_P is more tightly distributed
189 about the local mean at greater angles to the c -axis in all four samples. This is not related to the
190 measurements but to the c -axis projection, which funnels tracks at higher angles to the c -axis into
191 a narrower length interval than those at lower angles (Donelick et al., 1999). The c -axis projection
192 thus trades the unequal means l_{PM} of the length distributions at different c -axis angles for unequal
193 standard deviations S_{PM} . The effect is quite pronounced; the standard deviations of all confined
194 tracks lengths at <15° to the c -axis are on average twice as high as those of tracks at >75° to the
195 c -axis (**Figures 3b and B1** of Appendix B). In the case of sample 21-3, S_{PM} decreases from ~0.8
196 μm at ~0° to the c -axis to ~0.2 μm at ~90°. It is not clear how this affects thermal histories mod-
197 elled using c -axis projection, but it would appear that careful accounting for the orientations of
198 the measured tracks is essential to avoid artefacts.

199 **Figure B2** of appendix B shows the length histograms of tracks at 15° angular intervals, projected
200 onto the c -axis while preserving length differences, i.e., keeping the distance from each data point
201 to the fitted ellipse fixed. This eliminates length anisotropy without affecting the distributions
202 about the means. However, because it applies to tracks annealed under identical conditions and
203 not to variable-temperature histories it is of no use for modelling. It is nevertheless interesting to
204 contrast both projections. The latter understands each length measurement as an estimate of the
205 mean length in a given orientation but departing from it due to accidents of track formation and
206 etching, but not due to annealing. The former interprets each single length measurement as the
207 mean of a population, whose value is a direct reflection of its annealing history, excluding random
208 effects. As we understand it, the former is assumption more correct but the latter a condition for
209 modelling.

210 However the assumption implicit in the common c -axis projection has interesting implications.
211 In contrast to individual track lengths, two mean track lengths projected onto the c -axis differ due
212 to their thermal histories, not due to accidents of track formation or etching, which do not affect
213 the means. Since annealing unidirectionally lowers the mean lengths, a population with a shorter



214 **Figure 2.** Measured (a-d) and c-axis projected (e-h) lengths of induced horizontal confined tracks
 215 in the four studied samples plotted against angle to the c-axis: (a, e): unannealed; (b, f): annealed
 216 10 h at 240 °C; (c, g): annealed 10 h at 288 °C and (d, h) annealed 10 h at 310 °C (Ketcham et al.,
 217 2015). White circles: continuous tracks; grey circles: stepped tracks; black circles: gapped tracks.
 218 The solid lines in a-d are ellipses fitted to the data (excluding data for stepped and gapped tracks
 219 in d); those in e-h are linear regression lines; n: number of measured lengths; l_M : mean track
 220 length; σ_M : standard deviation of the length distribution; l_C : c-axis intercept of the fitted ellipse; l_A :
 221 a-axis intercept of the ellipse; l_{PM} : mean c-axis projected length; σ_{PM} : standard deviation of the c-
 222 axis projected lengths; l_{PC} : c-axis intercept of the fitted regression line; l_{PA} : a-axis intercept of the
 223 regression line.



224 **Figure 3.** (a) Relationship between the c -axis and a -axis intercepts of ellipses fitted to the measured
 225 lengths (white circles) and regression lines fitted to the c -axis projected lengths (grey circles) of
 226 confined tracks in the studies samples; solid lines represent published equations (RD: Donelick
 227 et al., 1999; 1:1: isotropic trend), dashed lines have been fitted to the measurements in this work;
 228 (b) relationship between the standard deviations and means of the distributions of the measured
 229 (white circles) and c -axis projected lengths (grey circles) of horizontal confined tracks in the stud-
 230 ies samples; the orange circles represent the standard deviations of tracks at $<15^\circ$ and $>75^\circ$ to the
 231 apatite c -axis.



Sample		$\phi(^{\circ})$	$l(\mu\text{m})$	$l_P(\mu\text{m})$	$r_o(\mu\text{m})$	$r_l(\mu\text{m})$	$s_l(\mu\text{m})$	$\theta(^{\circ})$	$d(\mu\text{m})$	$t_E(\text{s})$	v_T ($\mu\text{m}/\text{min}$)
21-2	Count	637	637	637	629	553	553	500	139	712	500
	Mean	53.1	16.1	16.4	0.68	0.53	7.56	2.92	1.00	11.0	208
	Error	0.89	0.03	0.02	0.01	0.01	0.10	0.07	0.02	0.12	22
	S.Dev	22.5	0.82	0.62	0.23	0.18	2.33	1.63	0.21	3.22	118
21-4	Count	374	372	372	337	337	337	335	49	366	335
	Mean	54.2	14.6	15.4	0.79	0.63	6.04	3.53	1.05	11.9	165
	Error	1.10	0.04	0.03	0.01	0.01	0.16	0.10	0.03	0.17	18
	S.Dev	21.2	0.82	0.57	0.22	0.19	2.86	1.80	0.21	3.26	84
21-1	Count	320	320	320	308	281	281	213	66	249	209
	Mean	53.5	12.5	13.9	0.76	0.63	5.96	3.14	1.33	12.0	201
	Error	1.23	0.05	0.03	0.02	0.01	0.11	0.13	0.03	0.21	14.0
	S.Dev	21.9	0.94	0.53	0.27	0.23	1.87	1.89	0.28	3.37	115
21-3	Count	821	821	821	724	713	713	684	165	826	684
	Mean	53.2	10.4	12.6	0.67	0.52	4.93	4.03	1.00	10.6	159
	Error	0.77	0.05	0.02	0.01	0.01	0.07	0.11	0.02	0.12	26
	S.Dev	22.1	1.53	0.54	0.20	0.16	1.92	2.94	0.23	3.37	91

232 **Table 1A.** Average c -axis angles, lengths and widths of horizontal confined induced tracks in
 233 prism faces of Durango apatite and calculated track effective etch times t_E and track etch rates
 234 v_T . Etching conditions: 20 s in 5.5 M HNO_3 at 21 °C; the different measured lengths and widths
 235 are shown in Figure 1.

Sample		$\phi(^{\circ})$	$l(\mu\text{m})$	$l_P(\mu\text{m})$	$r_o(\mu\text{m})$	$r_l(\mu\text{m})$	$s_l(\mu\text{m})$	$\theta(^{\circ})$	$d(\mu\text{m})$	$t_E(\text{s})$	v_T ($\mu\text{m}/\text{min}$)
Continu- ous	Count	731	731	732	668	658	658	629	103	735	629
	Mean	50.6	10.7	12.7	0.66	0.52	4.86	3.56	0.97	10.7	82
	Error	0.80	0.05	0.02	0.01	0.01	0.07	0.08	0.02	0.13	1.9
	S.Dev	21.7	1.26	0.54	0.20	0.16	1.92	2.00	0.25	3.48	48
Stepped	Count	78	78	61	50	49	49	49	52	79	49
	Mean	73.9	8.93	12.6	0.89	0.42	5.90	10.1	1.05	10.3	39
	Error	1.31	0.17	0.04	0.02	0.02	0.21	0.77	0.03	0.23	3.0
	S.Dev	11.6	1.50	0.31	0.17	0.14	1.44	5.41	0.18	2.04	21
Gapped	Count	12	12	12	6	6	6	6	10	12	6
	Mean	76.6	5.02	11.9	0.58	0.49	4.14	3.51	1.00	8.52	152
	Error	3.76	0.27	0.11	0.08	0.08	1.30	1.09	0.07	0.82	49
	S.Dev	13.0	0.95	0.39	0.20	0.19	3.20	2.67	0.21	2.84	119

236 **Table 1B.** Breakdown of the data for sample 21-3 in Table 1A according to the appearance of
 237 the etched track (Figure 1; continuous, stepped or gapped).



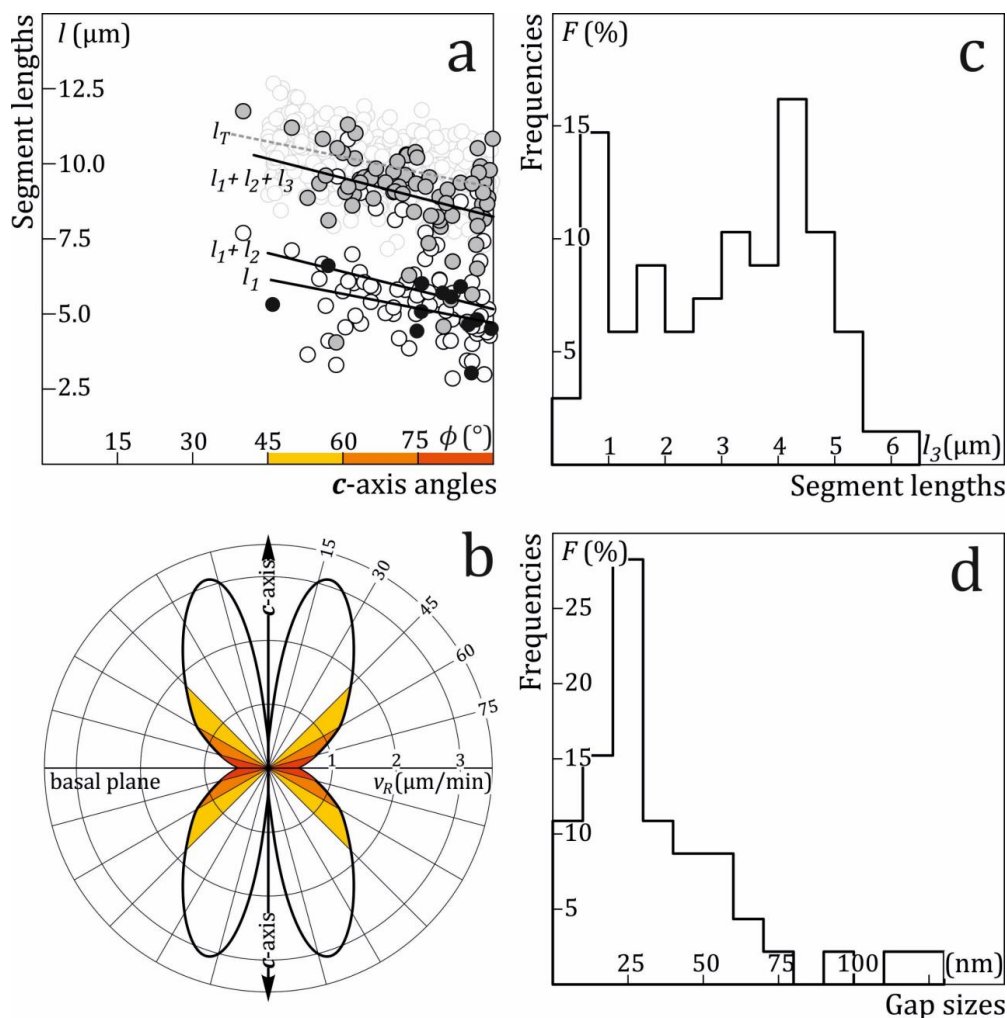
238 mean length has experienced more severe annealing than one with a longer mean length. Thus,
239 the order of projected lengths corresponds to the order of formation of the tracks. The number and
240 lengths of confined tracks thus divide a sample's history in a corresponding number of time-intervals
241 to each of which corresponds a specific mean length. This allows to convert its age and length
242 distribution directly to a Tt-path, without the need to search Tt-space. Allowance can be made for
243 biases, e.g., the fact that shorter tracks represent a larger population and time interval than longer
244 tracks. The uncertainties concerning the exact time of formation of each population can also be
245 taken into consideration (Jonckheere and Ratschbacher, 2010). The single solution represents
246 the core of the set of T,t-solutions consistent with the data and measurement uncertainties
247 (Rebetez et al., 1994).

248 Sample 21-3 is characterized by the occurrence of gapped and stepped tracks (**Figure 1**) at
249 $>45^\circ$ to the *c*-axis (**Figure 2d**). This is less than the calculated value for Durango apatite, both
250 for the predicted ($\phi_{air} >60^\circ$; ϕ_{air} = angle of accelerated length reduction; Donelick et al., 1999)
251 and the measured lengths ($\phi_{air} >80^\circ$). The occurrence of stepped and gapped tracks increases
252 with increasing angle to the *c*-axis (**Figure 4a**). This correlates with a rapid drop of the apatite
253 etch rate along the track axis from $<2 \mu\text{m}/\text{min}$ at 45° to $\sim 0.5 \mu\text{m}/\text{min}$ perpendicular to the *c*-
254 axis (**Figure 4b**). This, together with the simultaneous appearance of gapped and stepped
255 tracks, argues for the formation of non-etchable gaps (Green et al., 1986) rather than for a more
256 general form of accelerated length reduction (Donelick et al., 1999), and therefore for a breakup
257 of the tracks and a discontinuous structure of latent tracks (Paul and Fitzgerald, 1992; Paul,
258 1993). It appears that *c*-axis projection converts the lengths of gapped and stepped tracks to
259 values within a narrow length interval that depends little on their original lengths and orienta-
260 tions. It thus seems that less precise measurements of these lengths or orientations are not a
261 great concern.

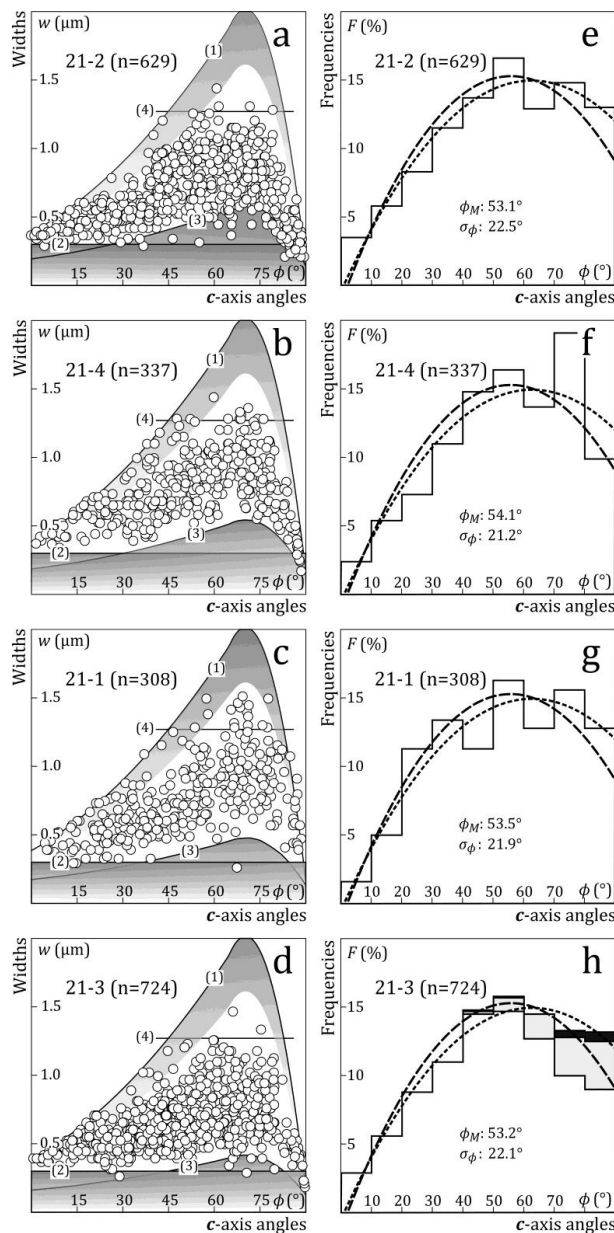
262 The gapped tracks in sample 21-3 have lengths $<7 \mu\text{m}$ (**Figure 1h**; Green et al., 1986), which is
263 somewhat shorter than the main segments of the stepped tracks, intersected by the host tracks
264 (**Figure 1g**; $l_1 + l_2$). The total lengths of the stepped tracks, including the section after the gap
265 (**Figure 1g**; l_3), are on average $\sim 0.2 \mu\text{m}$ shorter than continuous tracks with the same orienta-
266 tions (**Figure 4a**; l_t) due to the delay caused by the gap. The lengths of continuous tracks (l_t), the
267 final lengths of stepped tracks ($l_1 + l_2 + l_3$), that of their main sections ($l_1 + l_2$), and even the lengths
268 of gapped tracks (l_g) appear to exhibit a similar linear decrease with increasing angle to the *c*-
269 axis. In contrast, l_3 exhibits no visible dependence on orientation and no discernible preferred
270 length between zero and half the total track length (**Figure 4c**). This suggests that non-etchable
271 gaps can form more or less along the entire length of the tracks at this stage of annealing. Substi-
272 tuting r_1 and r_3 for r_0 in equation (1a) we calculated the difference of the effective etch time $\Delta t_{E1,3}$
273 on either side of the gap and interpreted it as the time required to pierce the gap at the etch rate
274 of undamaged apatite v_R in the direction of the track in order to estimate the size of the gaps. The
275 results range from $<10 \text{ nm}$ to $>100 \text{ nm}$, with nevertheless a pronounced mode at $\sim 30 \text{ nm}$, which
276 is consistent with TEM observations on latent tracks (**Figure 4d**; Paul and Fitzgerald, 1992; Paul,
277 1993) (Table 3).

3.2 Track widths

278 **Figure 5** plots the widths of the confined track against their angles to the *c*-axis. The data for all
279 samples define a similar boomerang shape, with minima parallel and perpendicular to the *c*-axis,
280 and the greatest widths at $60\text{-}75^\circ$. The solid curve (1) defines the maximum achievable widths
281 after 20s immersion in 5.5 M HNO_3 , calculated with the etch rates of Aslanian et al. (2021). Few
282 tracks attain that width due to the variable but finite access times required for the etchant to
283 travel (etch) down the host tracks and across to the confined tracks (Rebetez et al., 1988;
284 Ketcham and Tamer, 2021). For illustration, the shaded band under (1) represents access times
285 of up to 4 seconds. There also appears to be a distinct lower limit (2), which we interpret as the
286 minimum width for a track to be selected for measurement. Our lower limit at $\sim 0.3 \mu\text{m}$ is lower
287 than the value of Aslanian et al. (2021; $\sim 0.5 \mu\text{m}$), perhaps due to their longer immersion time or



288 **Figure 4.** (a) Measurements of stepped and gapped tracks plotted against angle to the c -axis (ϕ);
 289 white circles: lengths of the main sections of stepped tracks (**Figure 1g**; $l_1 + l_2$); grey: full lengths
 290 of stepped tracks ($l_1 + l_2 + l_3$); black: lengths of gapped tracks (l_1); grey-edged circles and dashed
 291 line show the full lengths of continuous tracks (l_T) in the same interval, for comparison; the colour-
 292 coding along the horizontal axis refers to angular intervals with decreasing apatite etch rates
 293 in the etch rate plot (b); (b) apatite etch rate plot from Aslanian et al. (2021), colour-coded to
 294 correspond with (a); (c) frequency distribution of the lengths of the distal segments of stepped
 295 tracks (l_3 ; past the constriction); (d) frequency distribution of the sizes of perforated gaps be-
 296 tween the main and distal segments of stepped tracks, calculated from the difference of the widths
 297 at r_1 and r_3 (**Figure 1g**).



298 **Figure 5. (a-d)** Widths of horizontal confined tracks (**Figure 1e**; r_0 ; excluding high-angle tracks)
 299 plotted against their angles to the c -axis (ϕ), and the main factors that guided their selection; (1)
 300 maximum width of confined tracks that started etching between 0 and 4 seconds after immer-
 301 sion; (2) overall minimum width of tracks accepted for measurement unless condition (3) ap-
 302 plies; (3) minimum width of a track etched to both ends, calculated using equation (6); (4) ap-
 303 proximate limit above which tracks close to the surface become too wide to remain confined; (**e-**
 304 **h**) distributions of track angles to the c -axis for the four studied samples; white: continuous
 305 tracks; grey: stepped tracks; black: gapped tracks; the short-dashed line is a polynomial fit to the
 306 combined data for the four samples (including high-angle tracks); the long-dashed line is a poly-
 307 nomial fit to the range of widths at each orientation delineated by constraints (1)-(4) (i.e., exclud-
 308 ing high-angle tracks).



309 to different track selection criteria. Over a broad range of orientations ($\lesssim 45^\circ$ to $\gtrsim 75^\circ$), the mini-
310 mum track widths are above this limit. This is due to the minimum time required for a track to
311 etch to its ends, so that it is suitable for measurement. For the sake of calculation, we assume that
312 both ends need to attain a width of $\sim 0.2 \mu\text{m}$ for a track to be measurable. Assuming that a track
313 of length l etches from the middle toward both ends, we find that $t_{E,MIN} = \frac{1}{2} (l/v_T + 0.2/v_R)$. The
314 corresponding minimum width is:

$$w_{MIN} (\mu\text{m}) = \left(\frac{l (\mu\text{m})}{2} \right) \left(\frac{v_R (\mu\text{m}/\text{min})}{v_T (\mu\text{m}/\text{min})} \right) + 0.2 (\mu\text{m}) \quad (6)$$

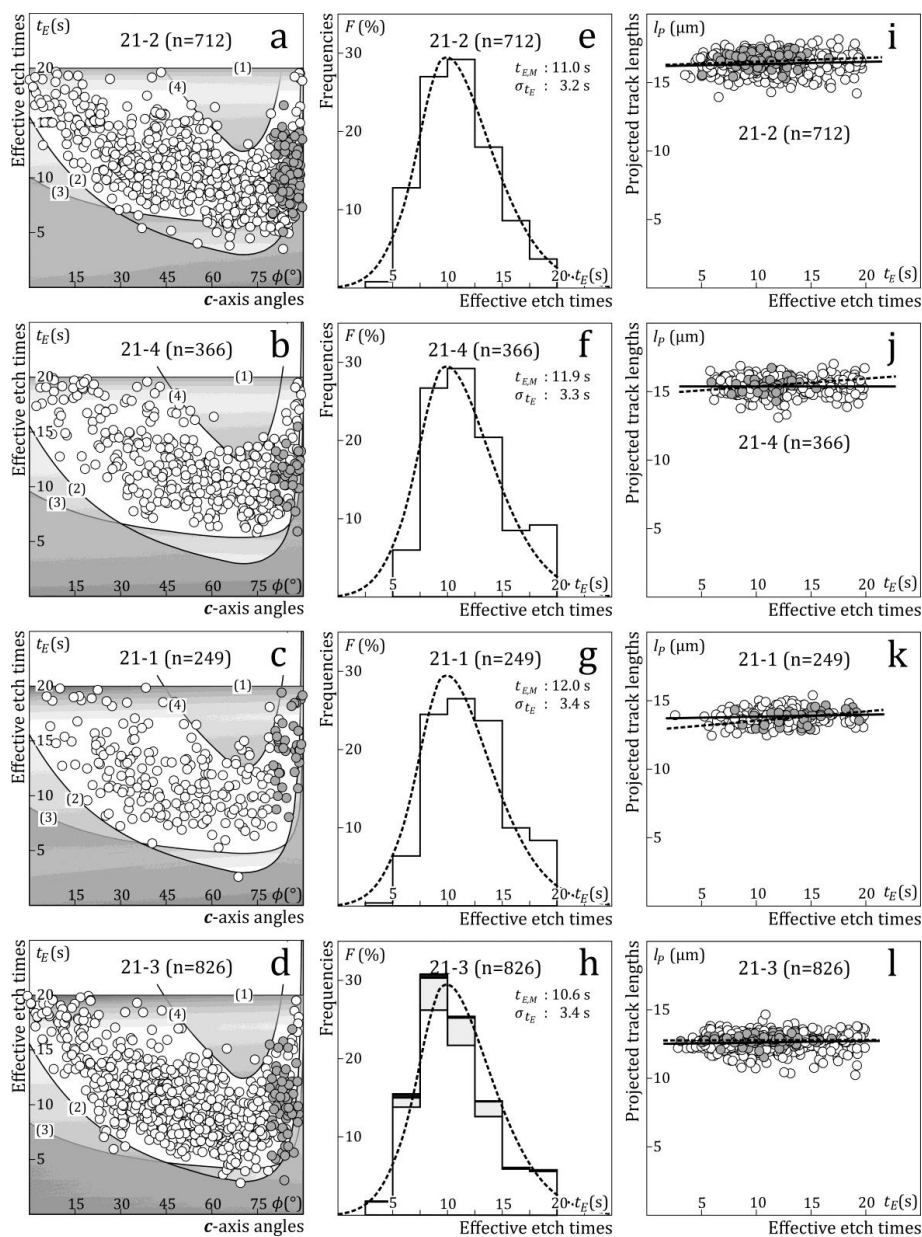
315 This estimate depends on both the length and orientation of the tracks, and is shown as curve (3)
316 in **Figure 5**. Despite the fact that these limits are diffuse, i.e., dependent on variable access times
317 and intersection points, they appear to constrain the data rather well, at least in a qualitative
318 manner. Within these bounds, there is nevertheless a conspicuous lack of tracks wider than ~ 1.25
319 μm at 60 - 75° to the c -axis (4). To attain greater widths the access times must be short, which
320 means that the tracks must be close to the surface, which is itself lowered at a slow rate during
321 the immersion of the sample. We conclude that the lack of tracks wider than $\sim 1.25 \mu\text{m}$ is due to
322 the fact that broad, shallow tracks come to intersect the surface as etching proceeds. This is a
323 form of surface proximity bias (Galbraith et al., 1990), although there is in our data no obvious
324 correlation with the track length.

325 The distance Δw between the lower of the upper limits (1 and 4) and the higher of the lower limits
326 (2 and 3) is proportional to the range of track widths consistent with these four criteria at a given
327 orientation. **Figures 5e-h** plot the average Δw for our four samples against angle to the c -axis,
328 ignoring the small differences between them. The result is a good fit to the combined and individ-
329 ual distributions of the track orientations. The agreement with the measured distributions is in
330 fact better than shown in **Figure 5e-h** since the latter include high-angle tracks not included in
331 **Figure 5a-d** because their effective etch times were calculated as in **Figure 1f**. This is an indica-
332 tion that etching- and observation-related factors have as least as much influence on the angular
333 frequencies of confined tracks as geometrical factors (Ketcham, 2003). The angular distributions
334 of our four samples are indistinguishable when the stepped and gapped tracks are included in
335 the measurements of the most annealed sample. This extends the range of constant angular bias
336 to within the domain of track break-up, i.e., somewhat beyond the limit assumed by Galbraith et
337 al. (1990) and Ketcham (2003).

338 Thus, in samples with low to moderate annealing, confined tracks are in the first place selected
339 based on their width, in the form of a minimum width independent of their length and orientation
340 (2) and of the rate of width increase (etch rate) in a given orientation, which determines the frac-
341 tion of tracks above the threshold (1). This selection is modified by factors depending on width
342 and length (3, 4), i.e., surface proximity bias (Galbraith et al., 1990) and the fact that longer tracks
343 on average attain a greater width before they are etched to their ends (Laslett et al., 1984). How-
344 ever, the influence of the track length on the angular frequencies of horizontal tracks is not no-
345 ticeable within the resolution of our measurements and the annealing range of our samples ($l_M =$
346 16.1 - $10.5 \mu\text{m}$). It seems fitting to describe these as "(under-)etching biases" (Ketcham 2003). At
347 advanced stages of annealing, track selection comes to be controlled by "track loss" (Green et al.,
348 1986; Ketcham, 2003).

3.3 Effective etch time

349 **Figures 6a-d** plot the effective etch times t_E of individual confined tracks against their angles to
350 the c -axis; t_E is calculated from the widths in **Figure 5a-d** using equations (1a) and (2a-b) and the
351 apatite etch rates of Aslanian et al. (2021). The effective etch times of the high-angle tracks (ϕ
352 $> 80^\circ$), not included in **Figure 5a-d**, are calculated with equation (1b) and plotted with a different
353 symbol; the two estimates are consistent with each other. The selection boundaries (1-4) are con-
354 verted to effective etch time limits in the same manner. Together the data again define boomer-
355 ang shapes, although inverted compared to those in **Figure 5a-d**, with the thinnest tracks at low



356 **Figure 6.** (a-d) Effective etch times of horizontal confined tracks (t_E) in the four studied samples
 357 plotted against their angles to the c -axis (ϕ), and the main factors, (1)-(4), that guided track se-
 358 lection, taken from **Figure 5**; white: low and moderate angle tracks (**Figure 1e**); grey: high-angle
 359 tracks (**Figure 1f**); (e-h) effective etch time distributions for the four studied samples; white: con-
 360 tinuous tracks; grey: stepped tracks; black: gapped tracks; the short-dashed line is a polynomial fit
 361 to the combined data for the four samples; t_{EM} and s_{tE} : arithmetic mean and standard deviation of
 362 the etch-time distribution (i-l) c -axis projected lengths (l_p) of confined tracks plotted against their
 363 effective etch times (t_E); white: low and moderate angle tracks (**Figure 1e**); grey: high-angle tracks
 364 (**Figure 1f**); the solid black line is a linear regression line fitted to the low and moderate angle
 365 data (white); the dashed line is a regression line fitted to the high-angle (grey).



366 and high angles to the *c*-axis having the longest etch times and the broadest tracks the shortest.
367 This illustrates the fact that those tracks are selected that have the right properties for being se-
368 lected and that the dominant selection criterion across all samples, lengths and orientations is
369 width. Longer low-angle tracks and shorter high-angle tracks widen at a comparable slow rate
370 (Aslanian et al., 2021) and are both measured after etch times close to the total immersion time,
371 while tracks in intermediate orientations, which widen at a faster rate, are selected after a shorter
372 time. High-angle tracks like that in **Figure 1b** are an exception because their effective etch time
373 is calculated from the diamond shaped figure at its intersection with the host track (Jonckheere
374 et al., 2022).

375 The etch time distributions are all right skewed, with similar means and standard deviations (**Fig-**
376 **ure 6e-h**). This might be unexpected, given the different track lengths and densities of the sam-
377 ples (Aslanian et al., 2022), which affect the number and length of the host tracks, their distances
378 to the nearest confined tracks, and therefore the access time and the etch time distributions. The
379 distributions in **Figure 6e-h** are however those of *selected* tracks, not of the sampled population
380 as such, and as long as it contains tracks meeting fixed selection criteria their distribution remains
381 the same. The etch time distribution is controlled by the threshold width (2) and the immersion
382 time (1). This does not exclude geometrical biases; apart from through length bias (Laslett et al.,
383 1982), track length influences the selection through constraints (3) and (4). However, their effect
384 on samples with simple length distributions, like those investigated here, appears to be small.
385 The operator influences track selection through the threshold width (2) and the assessment
386 whether tracks are etched to their ends (3). These decisions are not independent as a high thresh-
387 old width implies that most selected tracks are etched to their ends. E.g., **Figure 6a-d** suggests
388 that a threshold width of $\sim 0.7 \mu\text{m}$ would ensure that all selected track lengths are suitable for
389 measurement. The actual value is somewhat higher because (3) refers to tracks etched from the
390 middle towards both ends. A track that etches from one end towards the other requires a longer
391 etch time, during which it acquires a greater thickness; equation (6) is also based on rather *ad*
392 *hoc* estimates but the conclusion stands. **Figure 6e-h** shows, based on the same reasoning and
393 with the same proviso, that most tracks etched for an effective duration of ~ 10 seconds are
394 etched to their ends, which lends support to the (20 + 10)-s etching protocol proposed by Tamer
395 and Ketcham (2023).

396 We cannot, at this stage, estimate the precise effects of each constraint on the confined track se-
397 lection, but we can make a distinction between hard constraints (1) and (2) and soft constraints
398 (3) and (4), which depend on the track length, but have less effect on the selection. The threshold
399 width (2) can shift over a fraction of a micrometre depending on the operator, but the maximum
400 width (1) is a function of the immersion time and the anisotropic apatite etch rate. In conse-
401 quence, the confined track sample selected for measurement will depend on the immersion time
402 and etch rate, and thus on the etchant and apatite compositions. This means that the anisotropic
403 apatite etch rate is the main cause of the different angular distributions of confined tracks in ap-
404 atites with different $D_{\text{per}}/D_{\text{par}}$ ratios (Barbarand et al., 2003; Ketcham, 2003; Ravenhurst et al.,
405 2003). However, not because of a target-projectile relationship (Galbraith et al., 1990; Galbraith,
406 2002; Ketcham, 2003) but because of the variation of the apatite etch rate with orientation
407 (Aslanian et al., 2021).

408 A series of recent studies throw light on the influence of the etching protocol, experimental con-
409 ditions (transmitted vs. reflected light) and selection criteria on measurements of step-etched
410 confined tracks in Durango apatite (Tamer et al., 2019; Tamer and Ketcham, 2020; 2023;
411 Ketcham and Tamer, 2021). The overall conclusion is that substantial differences of the measured
412 mean track length arise from the etching protocol and selection but less from the actual measure-
413 ments. Individual mean lengths 10-20 standard errors from the overall sample means (Ketcham
414 et al., 2015) are interpreted as due to differences in the evaluation of the roundedness of the
415 etched track ends. This contrasts with the excellent agreement of our current measurements of
416 the same samples with the annealing models based on the calibration data of Carlson et al. (1999).
417 We submit that if track selection is indeed for the most part controlled by constraints (1) and (2),
418 with modifications from (3) and (4), as our single-track data indicate, then it must be possible to
419 perform reproducible and meaningful confined track length measurements which are suitable



420 for modelling. An unbiased systematic search for horizontal confined tracks using transmitted
421 light is adequate for this purpose. Deliberate or inadvertent biasing, carelessness or inexperience
422 will affect the results, but these should be treated as statistical outliers, not as an indication that
423 track lengths are fluid.

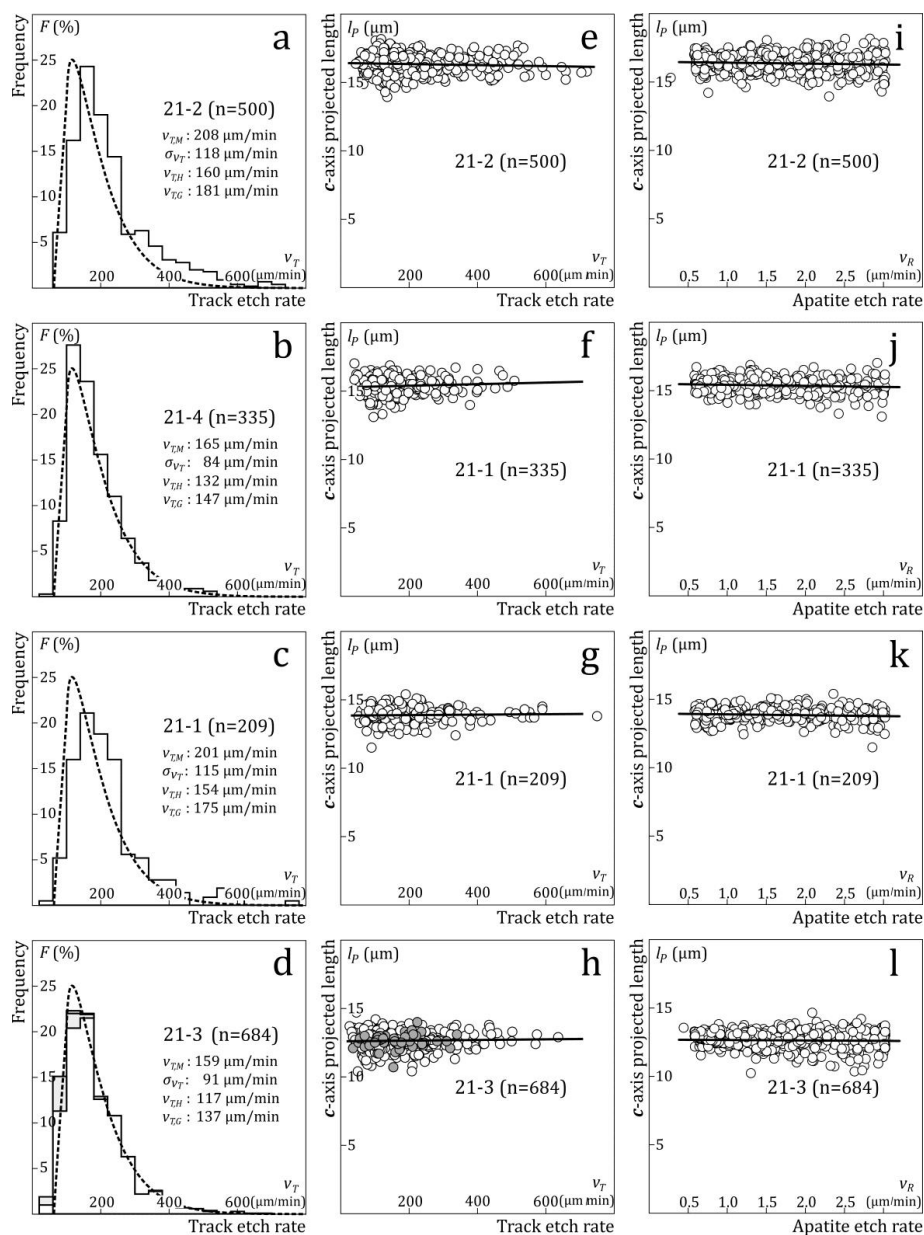
424 **Figure 6i-l** shows a weak positive correlation between the *c*-axis projected lengths and effective
425 etch times of individual confined tracks. Precise rates of increase are difficult to estimate because
426 of the weak correlation and large scatter of t_E and l_P . The best estimate is based on the high-angle
427 tracks because their etch times are calculated from the greatest widths and a single etch rate
428 (**Figure 1f**; equation 1b). The result (2.3 $\mu\text{m}/\text{min}$) is somewhat lower than the value for fossil
429 tracks, which drops from 3.4 $\mu\text{m}/\text{min}$ at 5 s to 2.9 $\mu\text{m}/\text{min}$ at 20 s (Aslanian et al., 2021). It is
430 closer to the rate for the non-projected lengths of fossil and induced tracks reported by Tamer
431 and Ketcham (2020; 2.6 $\mu\text{m}/\text{min}$).

3.4 Track etch rate

432 The calculated track etch rates span an order of magnitude (60-600 $\mu\text{m}/\text{min}$) in all samples and
433 the v_T -distributions are right-skewed in each case (**Figure 7a-d**). This can be a measurement ef-
434 fect because v_T is obtained by from the apatite etch rate v_R perpendicular to the track margins and
435 the subtended angle θ (equation 3a). Because θ averages 3-4° and is difficult to measure, signifi-
436 cant errors of 1° and more cannot be excluded. In that case, the harmonic mean v_T are less biased
437 central estimates than the arithmetic means. These range from ~160 $\mu\text{m}/\text{min}$ for the unannealed
438 sample to ~120 $\mu\text{m}/\text{min}$ for the most annealed. There is however no connection between the ext-
439 ent of partial annealing and the track etch rate. Given the uncertainties it is reasonable to sup-
440 pose that there is no demonstrable effect of annealing on the etch rate of induced tracks. The
441 overall mean (harmonic or arithmetic) for the four studied samples is ~140 $\mu\text{m}/\text{min}$. This is twice
442 the value for unannealed fossil tracks of Aslanian et al. (2021). Their arithmetic mean is 75
443 $\mu\text{m}/\text{min}$; the harmonic mean for the same data is ~63 $\mu\text{m}/\text{min}$. Even considering the uncertain-
444 ties, it appears that fossil tracks etch at a slower rate than comparable, partially annealed induced
445 tracks, which can be related to their different annealing behaviour (Wauschkuhn et al., 2015a).
446 Step-etch experiments also revealed differences between fossil and unannealed induced tracks
447 (Jonckheere et al., 2017).

448 Our calculation assumes that a single v_T value characterizes the entire track (equation 3a; **Figure**
449 **1e**). This implies a constant-core v_T -model rather than a linear model (Tamer and Ketcham, 2020;
450 Ketcham and Tamer, 2021), one in which the core extends over most of the etchable track length,
451 except for perhaps ~1 μm at either end, where the average etch rate drops as the damage be-
452 comes intermittent (Paul and Fitzgerald, 1992; Paul, 1993; Toulemonde et al., 1994; Li et al.,
453 2011; 2012). This is at variance with the view that v_T reflects the variation of the damage or di-
454 ameter along the track, resulting from its formation (Fleischer et al., 1969; Price et al., 1973). It is
455 nonetheless reasonable to consider that depleted, amorphous or porous track cores (Fleischer et
456 al., 1965; Szenes, 1996a; b; Li et al., 2010) could act as conduits along which the etchant advances
457 at a rate that does not depend on the degree of material depletion, disorder, or porousness of the
458 track core, but on the rate of fluid flow, the reaction rate, or the exchange rate of acid and reaction
459 products at the solid-fluid interface. This could explain the different (etchant-strength/etch-time)
460 protocols used for revealing fission tracks in apatite over much the same length, the revelation of
461 ion tracks from different particles with the same etchant, and the different shapes of etched tracks
462 produced with low and high acid concentrations (references in Jonckheere et al., 2017; Jonck-
463 heere and Van den haute, 1996).

464 Constant-core models avoid a number of problems of linear models, and those with variable v_T in
465 general. Due to the "motorboat effect", linear v_T models generate different-shaped confined tracks
466 depending on whether they are etched with the v_T -gradient, from their centre towards both ends,
467 or against the gradient, from one end towards the centre (Fleischer et al., 1969; 1975; Paretzke
468 et al., 1973). The track outlines in consequence exhibit concave and convex curvature not ob-
469 served in actual samples (**Figure 8**). The fact that confined tracks and surface tracks are straight



470 **Figure 7.** (a-d) Etch-rate (v_T) distributions of horizontal confined tracks in the four studied samples; white: continuous tracks; grey: stepped tracks; black: gapped tracks; the dashed line is a fit to
 471 the combined data; v_{TM} and σ_{v_T} : arithmetic means and standard deviations of the etch-rate distribu-
 472 tions; v_{TH} and v_{TG} : harmonic and geometric means; (e-h) c-axis projected lengths (l_p) plotted
 473 against the etch rates (v_T) of horizontal confined tracks; white: low and moderate angle tracks (Fig-
 474 ure 1e); grey: high-angle tracks (Figure 1f); the solid black lines are linear regression lines fitted
 475 to the combined data; (i-l) c-axis projected lengths (l_p) plotted against the apatite etch rates (v_R)
 476 in the direction of the tracks; the solid black lines are linear regression lines fitted to the combined
 477 data.
 478



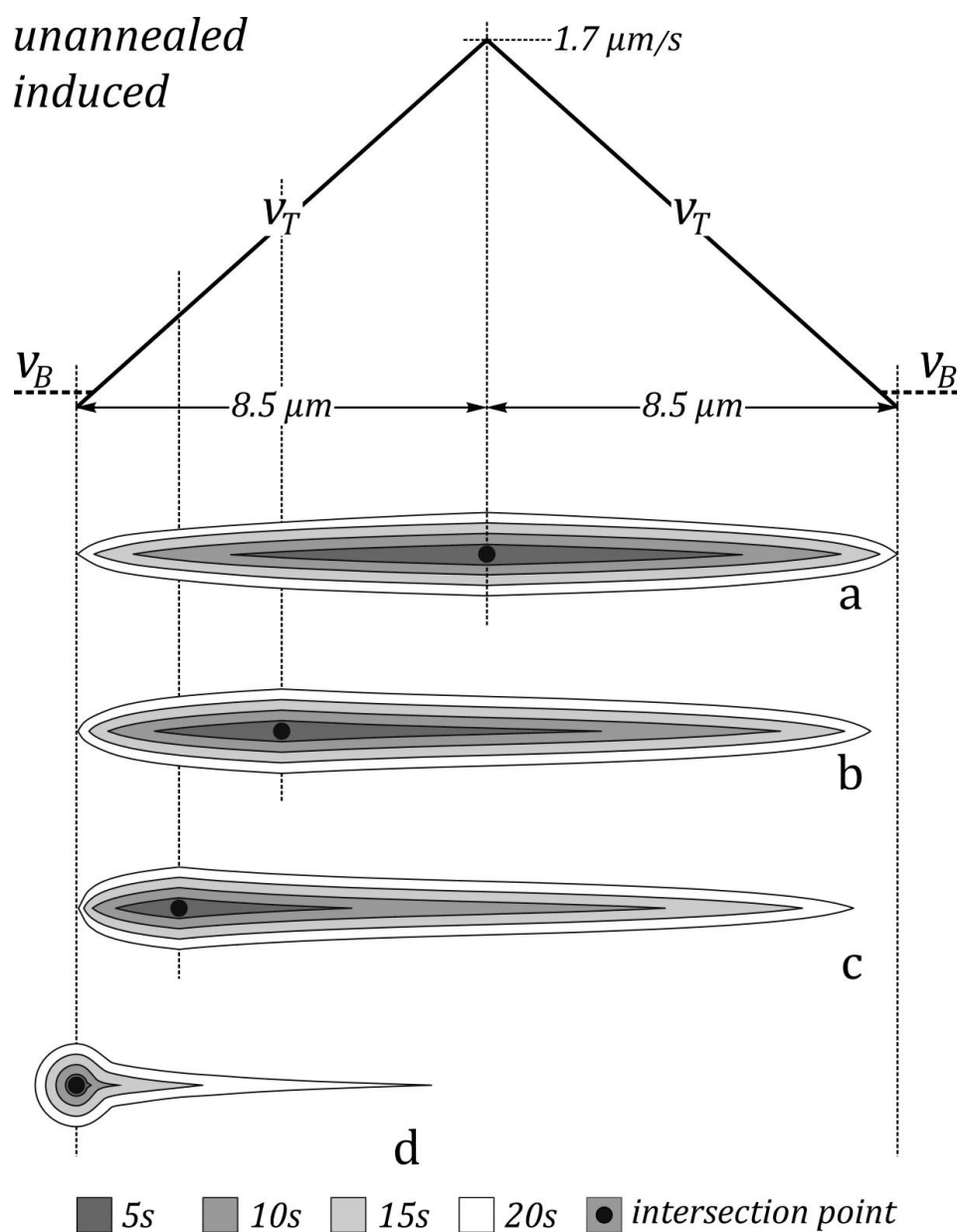
479 -edged irrespective of whether etching started from the centre or from the end is in itself a strong
480 indication of a constant v_T (Figure 9). A linear v_T model creates an excess of underetched tracks,
481 e.g., whenever etching starts at the end of a track or its effective etch time is less than the immer-
482 sion time (Figure 8). It is possible that underetched confined tracks are not observed or not se-
483 lected for measurement (Ketcham and Tamer, 2021), but this is not the case for surface tracks,
484 which are not selected. Nevertheless, all measurement of surface tracks reveal a deficit of short
485 tracks rather than an excess (Dakowski, 1978; Grivet et al., 1993; Jonckheere et al., 1993; Jonck-
486 heere and Van den haute, 2002). Surface tracks with lengths approaching those of confined tracks
487 also could not exist (Figure 8d). On reflection, there are other difficulties with linear v_T models.
488 They predict that a substantial fraction of the confined tracks exhibit a rapid length increase at
489 the end of a standard immersion time, which is not observed in step-etch experiments (Jonckheere
490 et al., 2017; Tamer et al., 2019; Tamer and Ketcham, 2020, 2023). A linear model also implies that
491 a latent track cannot be etched over its entire length at the track etch rate v_T in less than infinite
492 time as $v_T \rightarrow 0$ at its ends.

493 Our findings support a constant-core model extending over most of the etchable length of a track.
494 Nevertheless, v_T must decrease towards the ends (Figure 8 of Laslett et al., 1984; Figure 1 of Watt
495 and Durrani, 1985; Figures 7c and 8c of Aslanian et al., 2021). In a constant core model, it is not
496 obvious that this decrease correlates with a gradual change of the latent-track properties. Latent-
497 track and etched-track studies (Paul and Fitzgerald, 1992; Paul, 1993; Li et al., 2011; 2012;
498 Wauschkuhn et al., 2015b; Jonckheere et al., 2017) indicate an intermittent structure, made up of
499 damaged sections etching at a rate comparable to v_T , alternating with recrystallized sections etch-
500 ing at a rate comparable to the apatite etch rate v_R (unetchable gaps; Green et al., 1986). In that
501 case, the rate of length increase v_L is an average of v_T and v_R over a short section of track. A de-
502 creasing v_L towards the track tip causes it to become rounded (motorboat effect; Fleischer et al.,
503 1969; Ketcham and Tamer, 2021), until a gap cannot be breached and the end of the etched track
504 becomes bounded by basal and prism faces (Aslanian et al., 2021). The transition of rounded to
505 polygonal track tips would be the point at which an individual track is fully etched (Tamer and
506 Ketcham, 2023). Our results, however, reveal no correlation between the c -axis projected lengths
507 and the track (Figure 7e-h) or the apatite etch rate (Figure 7i-l). This can mean that no correla-
508 tion exists or that it is weak and obscured by the statistical variation of the length and etch-rate
509 measurements.

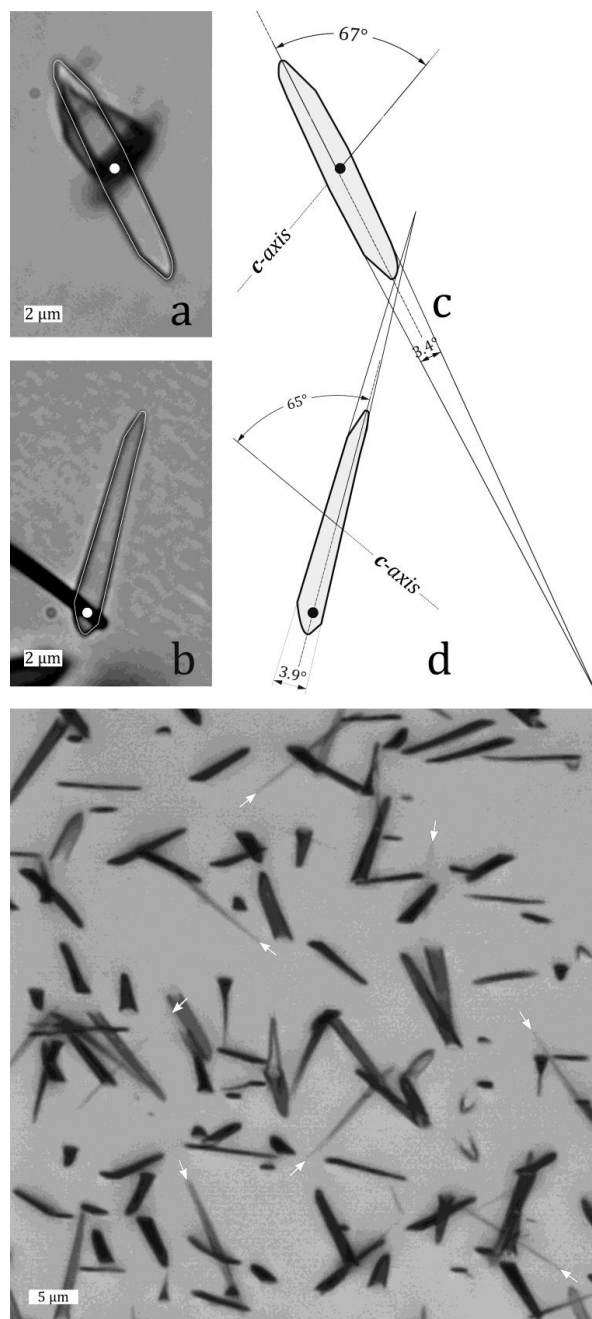
510 Considering that a constant-core model implies that v_T is insensitive to the properties of the latent
511 track, it is surprising that substantial differences appear to exist between individual tracks. At
512 this stage, we cannot exclude that most of the v_T -variation is related to its measurement and cal-
513 culation, and that induced fission tracks in apatite in fact have the same or a narrow range of v_T -
514 values. Even in that case, the harmonic means of our measurements provide valid first-order v_T -
515 estimates indicating that the cores of fossil and induced tracks etch at different rates. Price et al.
516 (1973) ascribed the different etching behaviour of "old" and "new" tracks in meteoritic minerals
517 to a rearrangement of the damage. In apatite, this phenomenon could be related to ageing (Gleadow
518 and Duddy, 1981) or seasoning (Durrani and Bull, 1987; Wauschkuhn et al., 2015a). However, the
519 significance of the core etch rates for the lengths of etched tracks is at present unclear (Ketcham
520 and Tamer, 2021).

4. Conclusions

521 Our investigation is concerned with the factors affecting the selection of confined tracks for mea-
522 surement and T,t-modelling. It was conducted on induced tracks in four prism sections of Durango
523 apatite etched for 20 s in 5.5 M HNO₃ at 21 °C. Their nominal mean track lengths are ~16, ~14,
524 ~12, and ~10 μm (Ketcham et al., 2015), and their transmitted-light track densities are between
525 ~2.9 and ~1.9 10⁶ cm⁻² (Aslanian et al., 2022). The tracks were selected by scanning the samples
526 in transmitted light using two conscious criteria: (1) the entire track could be captured in an im-
527 age stack with a depth of 1.25 μm; (2) both ends of the track were distinct. One operator collected
528 the images; the second vetted them, without deliberating with the first, and performed the meas-
529 urements. In order to characterize each selected track as fully as possible, these included length,
530 orientation, width, cone angle and other dimensions needed for calculating their individual effec-
531 tive etch times.



532 **Figure 8.** Geometries of unannealed induced confined tracks in apatite etched 20 s in 5.5 M HNO₃
533 at 21 °C, calculated with the linear v_T -model of Ketcham and Tamer (2021; Figure 15 and Table 2)
534 (a) track etched from the middle towards both ends; (b) confined track intersected at $\frac{1}{4}$ length
535 from one end; (c) at $\frac{1}{8}$ length; (d) at the end; brighter grey shades indicate increasing etch times
536 from 5 to 20 s.



537 **Figure 9.** Microscope images and contours of confined tracks with a host track intersections close to the middle (**a, c**) and close to the end (**b, d**), both showing straight edges indicative of a constant
538 v_T ; (**e**) compressed image stack of straight-edged surface tracks in a prism face of Durango apatite
539 etched 20 s in 5.5 M HNO_3 at 21 °C, showing no excess of short tracks or deficit of long tracks; the
540 fact that all confined tracks, however thin compared to surface tracks with the same orientations,
541 are etched over something approaching their full lengths also argues for a constant high track
542 etch rate (arrows).
543



544 In contrast to the large variation reported in Ketcham et al. (2015), our results are in good agree-
545 ment with the annealing equations and original data for this apatite and etchant (Carlson et al.,
546 1999; Ketcham et al., 1999). This leads us to question whether all variation between analysts can
547 be reduced to individual judgements as to which tracks are suitable for measurement (Ketcham
548 and Tamer, 2021). Our data show that c -axis projection (Donelick et al., 1999) eliminates all track
549 length variation with orientation but leads to a narrowing of the length distribution with increas-
550 ing angle to the c -axis, with consequences for T,t-modelling that merit thorough consideration.
551 Our sample annealed to a mean length of $\sim 10 \mu\text{m}$ contains segmented tracks, whose number in-
552 creases and whose length decreases with their angle to the c -axis, and thus with a decrease of the
553 apatite etch rate. Their appearance is due to a local obstruction delaying the progress of the etch-
554 ant, i.e., to unetchable gaps (Green et al., 1986) rather than accelerated length reduction (Donelick,
555 1991). Our measurements show that the gaps are between ~ 10 and $\sim 100 \text{ nm}$, with a mode at
556 $\sim 30 \text{ nm}$, confirming estimates based on transmission electron microscope observations (Paul
557 and Fitzgerald, 1992; Paul, 1993).

558 The confined track selection is in the first place determined by a threshold width and in the sec-
559 ond place by the requirement that the tracks are etched to their ends. In most cases the first con-
560 dition implies the second, which decreases in importance as the tracks are shortened by anneal-
561 ing. The remaining cases correspond to orientations in which the track width increases fastest
562 compared to its length. The selection is further limited by the fact that the widest confined tracks,
563 which are also the shallowest, come to intersect the surface, which eliminates them from consid-
564 eration. This is a surface proximity bias with the emphasis on the width rather than on the length
565 of the tracks (Galbraith et al., 1990; Galbraith, 2005). The number of suitable confined tracks at
566 each angle to the c -axis is proportional to the difference between the minimum and maximum
567 widths corresponding to these constraints. The angular distribution of the selected tracks is there-
568 fore a close reflection of the range of possible track widths, with little influence from geometric
569 biases. Because the confined track selection depends on the track widths rather than lengths, it
570 is almost unaffected by annealing, at least up to the point that selective track loss occurs. A change
571 of the etch rates, due to the etchant or apatite composition would in contrast have a definite effect
572 (Ketcham, 2003).

573 We calculated the true duration for which each individual confined track has been etched (effec-
574 tive etch time) from its width and the apatite etch rate perpendicular to its axis (Aslanian et al.,
575 2021). The results remain consistent with the constraints, converted to etch times in the same
576 manner. These are somewhat indistinct because they depend to an extent on the length of each
577 confined track and on where along its length the host track intersects it. In favourable orienta-
578 tions, an unannealed track intersected in the middle can etch in five seconds. This places a lower
579 limit $100 \mu\text{m}/\text{min}$ on the track etch rate. The etch time distributions are right-skewed with a
580 mode at just over half the immersion time. The thinnest tracks at low and high angles to the c -
581 axis need the longest etch times and also appear to be less affected by surface proximity bias than
582 the wider tracks. The etch time distribution shows no demonstrable dependence on the extent of
583 annealing despite the different geometrical relationship between the unetched host tracks and
584 confined tracks. This illustrates a principle known from other selection processes, *nl.* that those
585 entities are selected that have the right qualities for being selected, in this case the track width is
586 the overriding condition.

587 Our calculated track etch rates span an order of magnitude, with arithmetic means of 160 to 200
588 $\mu\text{m}/\text{min}$ and harmonic means of 120 to 160 $\mu\text{m}/\text{min}$. The v_T -distributions are right-skewed with
589 values ranging up to 600 $\mu\text{m}/\text{min}$, which are thought to be overestimates because the v_T -calcula-
590 tion is vulnerable to measurement error. In contrast to earlier reports (Tamer and Ketcham,
591 2020; Ketcham and Tamer, 2021), we find no evidence for an increase of v_T with annealing or for
592 variation of v_T along the tracks. We favour a constant etch rate over most of the track length be-
593 cause it seems inevitable that a linear model creates a great excess of short tracks, which even if
594 excluded from the confined track sample (Ketcham and Tamer, 2021), would produce a concave-
595 upwards distribution of the projected lengths of surface tracks (Laslett et al., 1982; Rebetz et al.,



596 1990), which is not supported by measurements (Dakowski, 1978; Grivet et al., 1993; Jonckheere
597 et al., 1993; Jonckheere and Van den haute, 2002). Calculation also shows that for a linear v_T -
598 model the etchant will often fail to reach the ends of the confined tracks within the standard im-
599 mersion time (**Figure 10**). A constant-core model does not have this drawback; for the mean etch
600 rates determined in this work (140 $\mu\text{m}/\text{min}$), it takes under seven seconds to etch the longest
601 track from end to end. A high v_T would also account for the common experience that almost all
602 the confined tracks in a sample have close to their full lengths, and for the fact that the measured
603 lengths exhibit no correlation with v_T . A high v_T would also limit the effect of several host tracks
604 intersecting a confined track, which we estimate to be negligible unless it is intersected at distant
605 points at the same time. This implies that the dependence of the track length on effective etch
606 time is a limited effect due to etching at its endpoints at a rate v_L intermediate between the track
607 and the apatite etch rates (Aslanian et al., 2021). The question of the track etch rate nevertheless
608 presents challenges as it seems reasonable that if v_T exhibits no variation along a track, it would
609 also show little variation from track to track. Our measured v_T also do not correlate with the ex-
610 tent of annealing of the induced tracks, but are nevertheless twice as high as the value for fossil
611 tracks (75 $\mu\text{m}/\text{min}$; Aslanian et al., 2021).

Supplement link

Author contribution

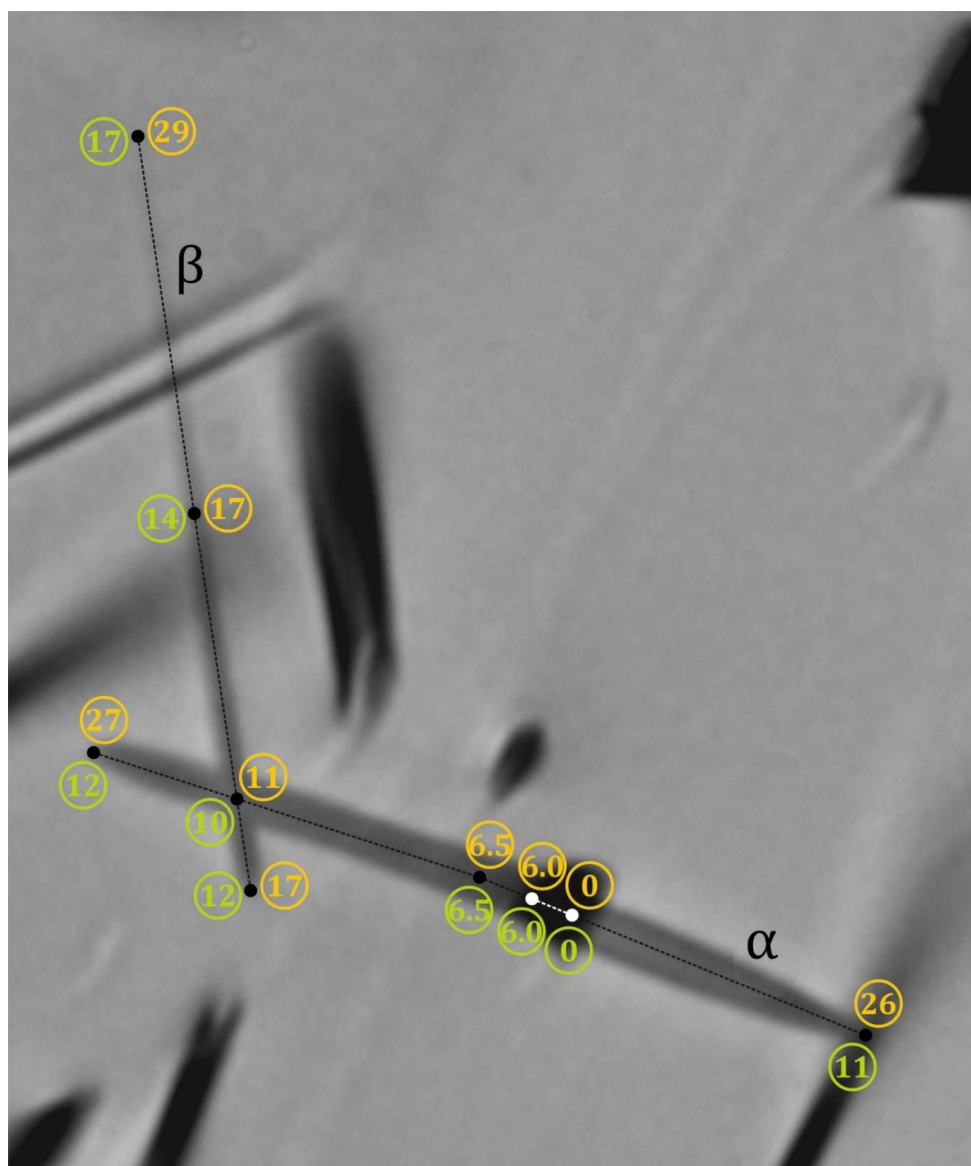
612 RJ designed the experiment, collected the microscope images, analysed the data and prepared the
613 manuscript. Dr. M.T. Tamer made a substantial contribution to the measurements but desires not
614 to be listed as co-author.

Competing interests

615 The author declares that he has no conflict of interest.

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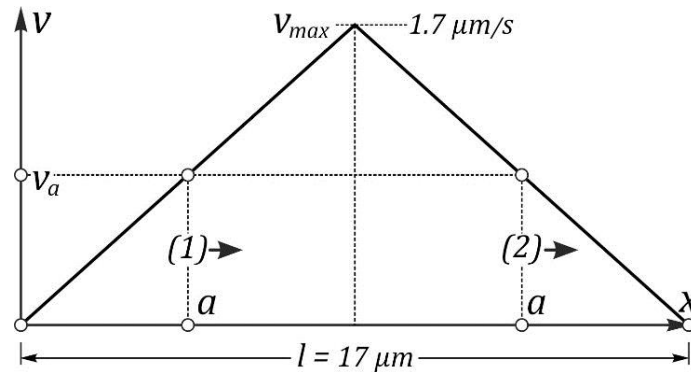
616 Funded by the German Science Foundation (DFG grant JO 358/4). I am pleased to acknowledge
617 contributions of Dr. M.T. Tamer, Dai Mengyao, Zhong Chang, Yaling Tao to the image processing
618 and measurements.



619 **Figure 10.** Comparison of etchant progress along an unannealed induced track-in-track-in-track
620 in Durango apatite etched 20 s in 5.5 M HNO₃ at 21 °C. Yellow: seconds after immersion based on
621 the linear model of Ketcham and Tamer (2021); green: seconds after immersion based on the
622 effective etch times and track etch rates calculated from the measured widths using the etch rates
623 of Aslanian et al. (2021). The etchant takes ~6 seconds to advance down the host track and across
624 to the intersection of α and β, and somewhat less along the main section of β. However, the calcula-
625 tions diverge towards the ends of both tracks due to the rapid decrease of the track etch rate in
626 the linear model. Because of the expenditure of ~6 seconds of etch time before the etchant can
627 begin to etch α, it is unable to reach the ends of α or β within the immersion time of the sample.
628 According to the calculation based on Aslanian et al. (2021) the etchant reaches the furthest end
629 of β with three seconds to spare, which is enough to widen it to ~0.2 μm and for it to be observed
630 and measured (Appendix A).
631



Appendix A: etch time calculation



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Figure A1. Linear etch rate model for unannealed induced tracks (after Ketcham and Tamer, 2021; Figure 15); (1) etching against the etch-rate gradient, (2) etching with the gradient.

$$\frac{dv}{dx} = c \quad (\text{A1}) \quad a - \frac{v_a}{c} = z \quad (\text{A11})$$

$$\frac{dv}{dt} \frac{dt}{dx} = c \quad (\text{A2}) \quad x = \frac{v_a}{c} e^{ct} + \left(a - \frac{v_a}{c}\right) \quad (\text{A12})$$

$$\frac{dv}{v} = c dt \quad (\text{A3}) \quad x = a + \frac{v_a}{c} (e^{ct} - 1) \quad (\text{A13})$$

$$\ln(v) = c t + u \quad (\text{A4})$$

$$t = 0 \rightarrow x = a \rightarrow v = v_a$$

$$\ln(v_a) = u \quad (\text{A5})$$

$$\ln\left(\frac{v}{v_a}\right) = c t \quad (\text{A6})$$

$$v = v_a e^{ct} \quad (\text{A7})$$

$$\frac{dx}{dt} = v_a e^{ct} \quad (\text{A8})$$

$$dx = v_a e^{ct} dt \quad (\text{A9})$$

$$x = \frac{v_a}{c} e^{ct} + z \quad (\text{A10})$$

$$t = 0 \rightarrow x = a$$

$$(1) \quad v_a = c a$$

$$x = a + \frac{c a}{c} (e^{ct} - 1) \quad (\text{A14})$$

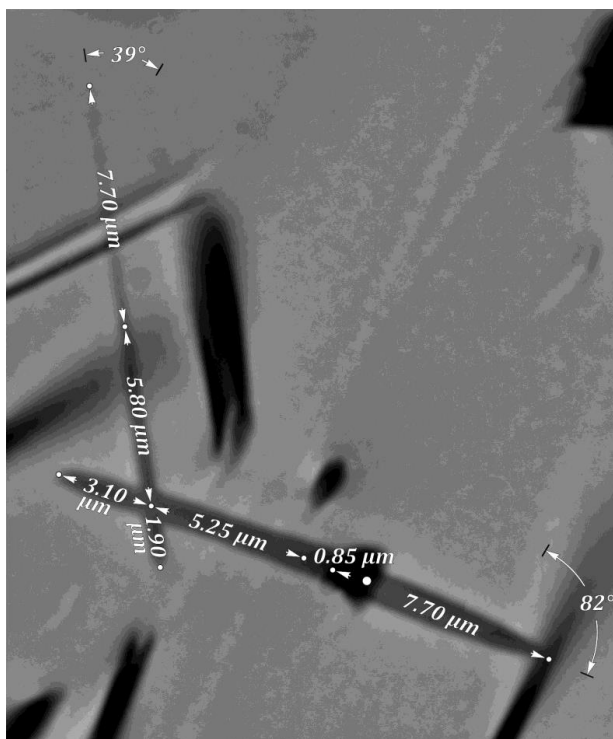
$$x = a e^{ct} \quad (\text{A15})$$

$$t = \frac{1}{c} \ln\left(\frac{x}{a}\right) \quad (\text{A16})$$

$$(2) \quad v_a = c \left(\frac{l}{2} - a\right)$$

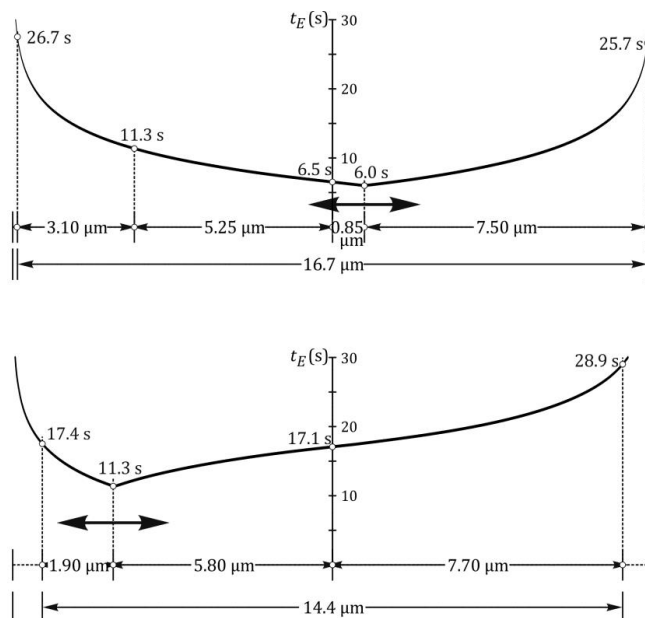
$$x = a + \left(\frac{l}{2} - a\right) (e^{ct} - 1) \quad (\text{A17})$$

$$t = \frac{1}{c} \ln\left(1 + \frac{2(x-a)}{(l-2a)}\right) \quad (\text{A18})$$



635
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Figure A2. A track-in-track-in-track in an apatite prism face etched 20 s in 5.5 M HNO₃ at 21 °C, with the orientations and lengths of different sections indicated.



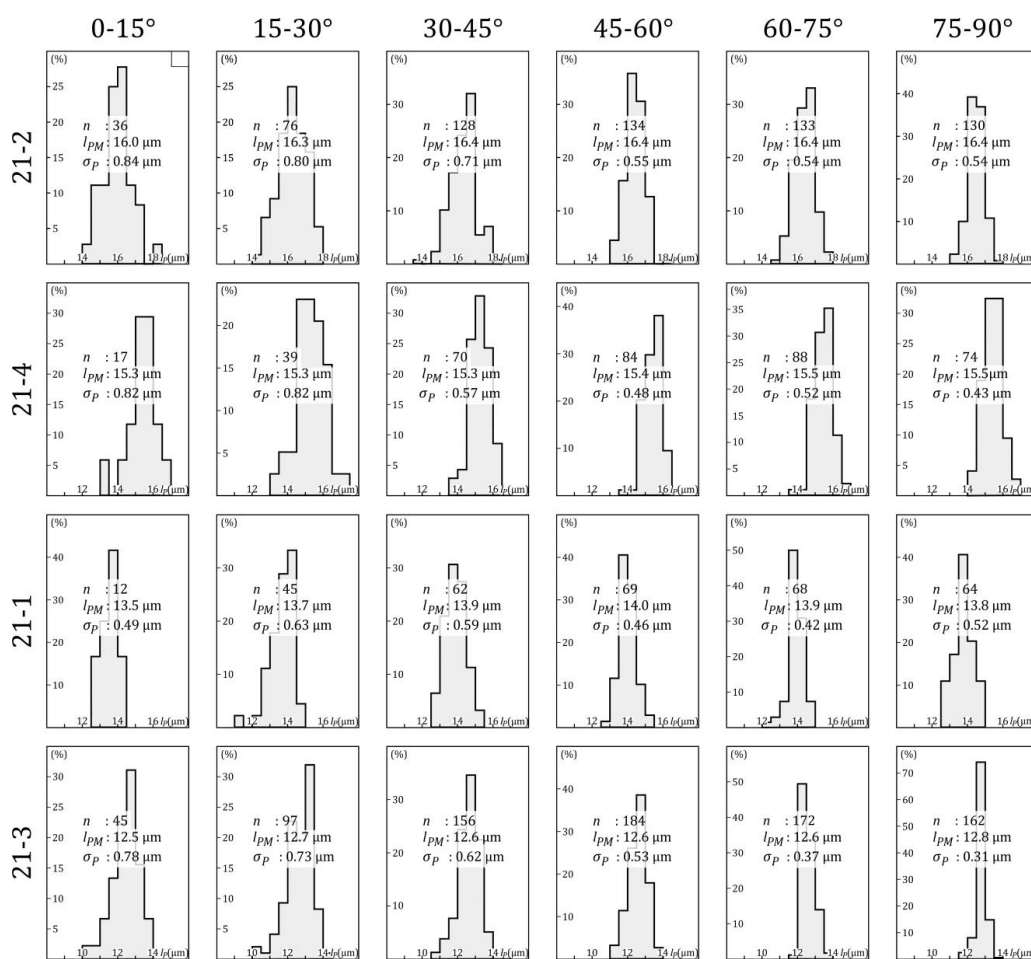
638

Figure A3. Calculated etch-time profiles of the tracks in Figure A2.

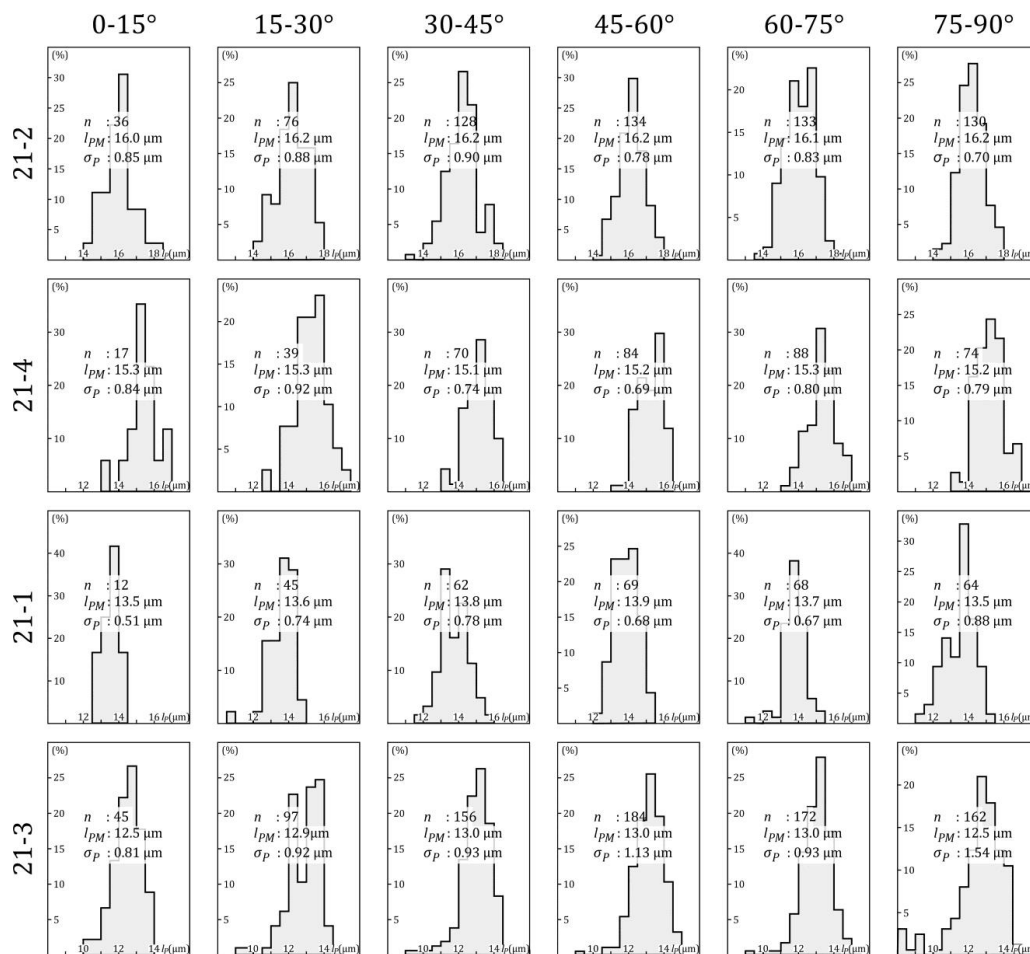


Appendix B: *c*-axis projections

639 This appendix shows a comparison of alternative *c*-axis projections of confined track lengths.
 640 **Figure B1** shows the results of the known method (Donelick et al., 1999), which is implemented
 641 in programs for modelling thermal histories. It assumes that each measured track length
 642 represents the mean of a different population. The projection in **Figure B2** assumes that each
 643 measured length represents a different track from the same population distributed about a single
 644 ellipse.



645 **Figure B1.** Normalized frequency distributions of the *c*-axis-projected track lengths in the four
 646 studied samples for populations within different angular intervals (15°) to the apatite *c*-axis. The
 647 different populations have consistent mean lengths but the standard deviations of the distributions
 648 show a marked decrease with increasing angle to the *c*-axis. This trend is clearest for sam-
 649 ples 21-2 and 21-3, which are based on a greater number of measurements; l_{PM} : mean; σ_P : stand-
 650 ard deviation.



651 **Figure B2.** Normalized frequency distributions of the *c*-axis-projected track lengths in the four
 652 studied samples for populations within different angular intervals (15°) to the apatite *c*-axis. For
 653 comparison with **Figure B1**, the projection preserves the absolute differences between individual
 654 lengths.



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